



A

Attorney Docket No. SON-1745
Date: February 23, 2000



ASSISTANT COMMISSIONER FOR PATENTS
Washington, D.C. 20231

Sir:

Transmitted herewith for filing is the patent application of

Inventor: Seiichi FUKUDA

For: DRY ETCHING METHOD AND METHOD OF MANUFACTURING
SEMICONDUCTOR APPARATUS

Enclosed are:

- ☒ Specification and Claim(s).
- ☒ Oath or Declaration
- ☒ six sheet(s) of drawings (2 sets)
- ☒ An assignment of the invention to Sony Corporation
- ☒ Copy of one priority application(s).
- ☐ Associate Power of Attorney.

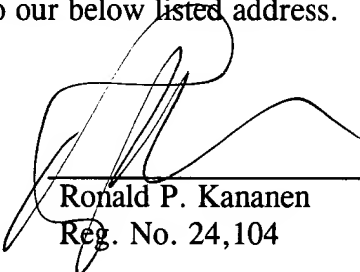
The fee has been calculated as shown below:

CLAIMS AS FILED				
FOR	NUMBER FILED	NUMBER EXTRA	RATE	BASIC FEE \$345/\$690
TOTAL CLAIMS	8-20	0	X \$ 9 \$18	
INDEP. CLAIMS	2-3	0	X \$39 \$78	
Fee for Multiple Dependent Claims \$130/\$260				0
			TOTAL FILING FEE	\$690

- ☐ A Preliminary Amendment is attached.
- ☐ Verified Statement claiming small entity status is enclosed.
- ☒ Charge \$ 690.00 to Deposit Account No. 18-0013 to cover the filing fee. A duplicate copy of this sheet is enclosed.
- ☒ The Commissioner is hereby authorized to charge any fees under 37 C.F.R. 1.16 or 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 18-0013. A duplicate copy of this sheet is enclosed.
- ☐ A check in the amount of \$ _____ over the filing fee is enclosed.
- ☐ Charge \$ _____ to Deposit Account No. 18-0013 to cover the recordal fee. A duplicate copy of this sheet is enclosed.
- ☒ Applicant's undersigned attorney may be reached by telephone in our Washington D.C. Office at

(202) 955-3750.

All correspondence should be directed to our below listed address.



Ronald P. Kananen
Reg. No. 24,104

RADER, FISHMAN & GRAUER, P.L.L.C
1233 20th Street, NW, Suite 501
Washington, DC 20036
Telephone: (202) 955-3750
Facsimile: (202) 955-3751